

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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CENTRAL FAX CENTER

Patent Application Serial No.....10/612,836
 Filing Date.....July 3, 2003
 InventorR. Wimer
 AssigneeMicron Technology, Inc.
 Group Art Unit.....2813
 ExaminerS.W. Smoot
 Attorney Docket No.....MI22-2263
 Title: Methods of Forming Deuterated Silicon Nitride Containing Materials

NOV 12 2004

Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1150

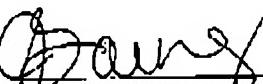
CERTIFICATE OF FACSIMILE TRANSMISSION UNDER 37 CFR § 1.8

I hereby certify that the following papers are being facsimile transmitted to the Patent and Trademark Office at (703) 872-9306 on the date shown below:

1. Certificate of Facsimile Transmission
2. Response to September 22, 2004 Office Action

Dated: November 12, 2004

By:


 Jennifer Gaines, Legal Assistant
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FEE DEFICIENCY

Although it is believed that no fees are due, the Commissioner is hereby authorized to charge any fees under 37 C.F.R. 1.16 and 1.17 which may be required by this paper to Deposit Account No. 23-0925.

Dated: November 12, 2004

By:


 David G. Latwesen, Ph.D.
 Reg. No. 38,533

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

NOV 12 2004

Application Serial No.10/612,836.....7185
Confirmation No.
Filing DateJuly 3, 2003
Inventor.....Ronald A. Weimer
AssigneeMicron Technology, Inc.
Group Art Unit.....2813
ExaminerStephen W. Smoot
Attorney's Docket No.MI22-2263
Customer No.021567
Title: Methods of Forming Deuterated Silicon Nitride Containing Materials

RESPONSE TO SEPTEMBER 22, 2004 OFFICE ACTION

To: Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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AMENDMENTS